## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE cation of: Jack O. Chu et al. : Date: April 1, 2003 No.: 09/989,770 : Group Art Unit: 2815 rmation No.: 2335 : Examiner: Jesse A. Fenty

Application of: Jack O. Chu et al.

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For: High Speed Composite p-Channel Si/SiGe Heterostructure for Field Effect Devices

Commissioner for Patents **Initial Patent Examination Division** Washington, D.C. 20231

## CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

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- 3. Response to Restriction Requirement;

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